



Docket No.: 60188-432

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yoshiaki HASEGAWA, et al.

Serial No.: 09/993,771¹

Group Art Unit: 2812

Filed: November 27, 2001

Examiner: SAVITRI MULPURI

For: METHOD FOR MANUFACTURING SEMICONDUCTOR AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Sir:

Noting the Office Action of June 25, 2003 wherein restriction has been required,
Applicant(s) hereby elect Species 1 as identified in the Office Action, and identify claim 4 as
reading thereon, for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby
made. Please charge any shortage in fees due in connection with the filing of this paper, including
extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit
account.

Respectfully submitted,

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Date: July 24, 2003